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020732-97.668 (7493)

MAR 27 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re United States Patent Application of:) Docket No.:	020732-97.668 (7493)
Applicants:) Conf. No.:	4823
Application No.:) Art Unit:	1752
Date Filed:) Examiner:	LE, Hoa Van
Title:) Customer No.:	24239
COMPOSITION AND PROCESS FOR POST-ETCH REMOVAL OF PHOTORESIST AND/OR SACRIFICIAL ANTI- REFLECTIVE MATERIAL DEPOSITED ON A SUBSTRATE))

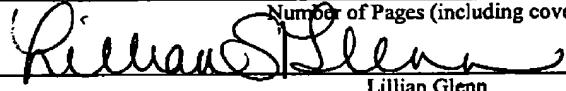
FACSIMILE TRANSMISSION CERTIFICATE

Attn: Examiner Hoa Van Le
Fax No. (571) 273-8300

I hereby certify that this document is being filed in the United States Patent and Trademark Office, via facsimile transmission to Mail Stop Amendment, Commissioner for Patents, PO Box 1450, Alexandria, VA 22313-1450, on March 27, 2006, to United States Patent and Trademark Office facsimile transmission number (571) 273-8300.

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Number of Pages (including cover)


Lillian Glenn

March 27, 2006

Date

RESPONSE TO MARCH 3, 2006 OFFICE ACTION IN UNITED STATES PATENT
APPLICATION NO. 10/792,038

Mail Stop Amendment
 Commissioner for Patents
 PO Box 1450
 Alexandria, VA 22313-1450

Sir:

Prior to examination of the above-identified patent application, please amend the claims, as set out in the following **Section I (the Claims)**.

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Remarks addressing the substance of the March 3, 2006 Office Action are set out in the **Section II (Remarks)** hereof.